

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Atsushi KUROKAWA et al.

Appln. No.:

Filed: HEREWITH

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

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PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified patent application as indicated below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 8 of this paper.